

DT05 Rec'd PCT/PTO 31 JAN 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:) PRODUCTION OF HIGH GRADE SILICON,
Per Kristian Egeberg) REACTOR, PARTICLE RECAPTURE
International App. No. PCT/NO2003/000263) TOWER AND USE OF THE
) AFOREMENTIONED
International Filing Date: July 30, 2003)
) Customer number: 27,717

PRELIMINARY AMENDMENT

Mail Stop: PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby submits the following Preliminary Amendment to the above referenced application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the claims begin on page 3 of this paper.